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APPLICATION NUMBER	FILING or 371(c) DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET.NO	TOT CLAIMS	IND CLAIMS
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# **CONFIRMATION NO. 5835**

FILING RECEIPT

8791 BLAKELY SOKOLOFF TAYLOR & ZAFMAN 12400 WILSHIRE BOULEVARD SEVENTH FLOOR LOS ANGELES. CA90025-1030

Date Mailed: 03/05/2007

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# Applicant(s)

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#### Assignment For Published Patent Application

Pfleiderer Water Systmes GMBH, Neumarkt, GERMANY

Power of Attorney: The patent practitioners associated with Customer Number 08791

### Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP05/13413 07/21/2005

# Foreign Applications

JAPAN 2004-214851 07/22/2004
JAPAN 2004-214856 07/22/2004
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JAPAN 2005-070723 03/14/2005
JAPAN 2005-070723 03/14/2005

### If Required, Foreign Filing License Granted: 02/07/2007

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is US10/566,522

Projected Publication Date: 05/17/2007

Non-Publication Request: No Early Publication Request: No

Title

Bistable resistance value acquisition device, manufacturing method thereof, metal oxide thin film, and manufacturing method thereof

# **Preliminary Class**

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